

**Official Communication
PATENT****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: Selzer
Application No.: 09/876,443
Filing Date: June 7, 2001
Title: Method of Improving X-Ray
Lithography in the Sub 100nm
Range to Create High Quality
Semiconductor Devices

Docket No. 1520-006 (1426)
Date: June 7, 2004
Group Art Unit: 2882
Examiner: I. Kiknadze
FAX: 703 872-9318
Pages sent: 1 and 4-14

**Corrected Amendment Under 37 CFR 1.111
Amendment F'**

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JUN 07 2004

Assistant Commissioner of Patents
Washington, D.C. 20231

Sir:

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This is in response to the Notice of Non-Compliant Amendment, dated June 4, 2004 and the office action dated February 26, 2004. This corrected amendment includes mention of claims 1-10 as being canceled on page 4. The only section of the amendment herein presented is the section regarding the amendment to the claims as provided in 37 CFR 1.21(h). The entire amendment to the claims is herein presented. If there is any further problem please contact applicant's attorney at 802 864-1575.

CERTIFICATE OF MAILING	
I hereby certify that, on the date shown below, this correspondence is being:	
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<input type="checkbox"/> deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner of Patents Washington, DC 20231.	<input checked="" type="checkbox"/> transmitted by facsimile to the Patent and Trademark Office.
Date: <u>6/7/04</u>	<u>James M. Leas</u> Name <u>[Signature]</u> Signature

1520-006 (1426)

Page 1 of 19

09/876,443